

AIDA-2020

Advanced European Infrastructures for Detectors at Accelerators

Presentation

Effects of protons and neutrons irradiation to the gain layer and bulk of 50-micron thick FBK LGAD sensors doped with Boron, Boron Low diffusion, Gallium, Carbonated Boron and Carbonated Gallium

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Effects of protons and neutrons irradiation to the gain layer and bulk of 50-micron thick FBK LGAD sensors doped with Boron, Boron Low diffusion, Gallium, Carbonated Boron and Carbonated Gallium

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Outline

ACCEPTOR REMOVAL

- Acceptor Removal effect on different flavors of gain layer (Boron, Gallium, Boron Low Diffusion, Carbonated Boron and Gallium)
- Comparison between acceptor removal due to Neutrons and Protons (24Gev/c)

ACCEPTOR CREATION

- Measurements of Acceptor Creation on PiN diodes (50µm thick) due to Neutrons & Protons irradiation and comparison with empiric model
 $N_A = g_{eff} \Phi$ ($g_{eff} = 0,02 \text{ cm}^{-1}$);

50µm UFSD, FBK Production

Wafer #	Dopant	Gain dose	Carbon	Diffusion
1	Boron	0.98		Low
2	Boron	1.00		Low
3	Boron	1.00		HIGH
4	Boron	1.00	Low	HIGH
5	Boron	1.00	HIGH	HIGH
6	Boron	1.02	Low	HIGH
7	Boron	1.02	HIGH	HIGH
8	Boron	1.02		HIGH
9	Boron	1.02		HIGH
10	Boron	1.04		HIGH
11	Gallium	1.00		Low
14	Gallium	1.04		Low
15	Gallium	1.04	Low	Low
16	Gallium	1.04	HIGH	Low
18	Gallium	1.08		Low

- 18 Wafers Silicon on Silicon (FZ), 50µm active thickness;
p-bulk acceptor density $\sim 2/3 \cdot 10^{12} \text{ cm}^{-3}$
- 5 different gain layer strategies:
 - **Boron** (Low and High Diffusion);
 - **Gallium** (Low Diffusion);
 - Carbonated **Boron** (B High Diffusion);
 - Carbonated **Gallium** (Ga Low Diffusion);
- 4 splits of dose (2% steps) for Boron Implant;
- 3 splits of dose (4% steps) for Gallium Implant;
- 2 carbon concentration (Low & High):
High Carbon = X10 Low Carbon:

5 Gain layer flavors to investigate the radiation damage

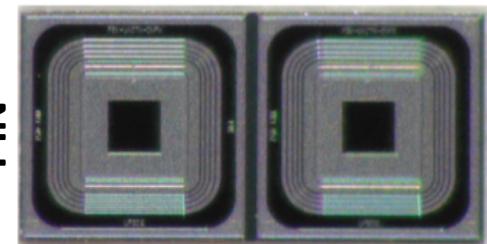
- **B Low Diffusion:** thinner gain implant could be more radiation resistance;
- **Gallium:** Ga could has a lower probability than B to became interstitial;
- **Carbon enrichment:** C could be traped by defects faster than Ga and B;



Irradiation campaign

Wafer #	Dopant	Gain dose	Carbon	Diffusion
1	Boron	0.98		Low
2	Boron	1.00		Low
3	Boron	1.00		HIGH
4	Boron	1.00	Low	HIGH
5	Boron	1.00	HIGH	HIGH
6	Boron	1.02	Low	HIGH
7	Boron	1.02	HIGH	HIGH
8	Boron	1.02		HIGH
9	Boron	1.02		HIGH
10	Boron	1.04		HIGH
11	Gallium	1.00		Low
14	Gallium	1.04		Low
15	Gallium	1.04	Low	Low
16	Gallium	1.04	HIGH	Low
18	Gallium	1.08		Low

Pairs of $1 \times 1 \text{ mm}^2$ PiN-LGAD



PiN

LGAD

Neutron Irradiation in Ljubljana

(AIDA2020) → thank you GK and friends!

Fluence steps:

$0,2/0,4/0,8/1,5/3/6/10 \times 10^{15} \text{ n}_{\text{eq}}/\text{cm}^2$

Proton Irradiation at CERN, 24Gev/c

(IRRAD) → Thank you Joern!

Fluence steps: $0,1/0,6/1/3/6/9 \times 10^{15}$

$\text{n}_{\text{eq}}/\text{cm}^2$ (NIEL Factor = 0,6)

Evolution of active acceptor density with fluence

$$N_A(\phi) = g_{eff}\phi + N_A(\phi = 0)e^{-c\phi}$$

ϕ = fluence

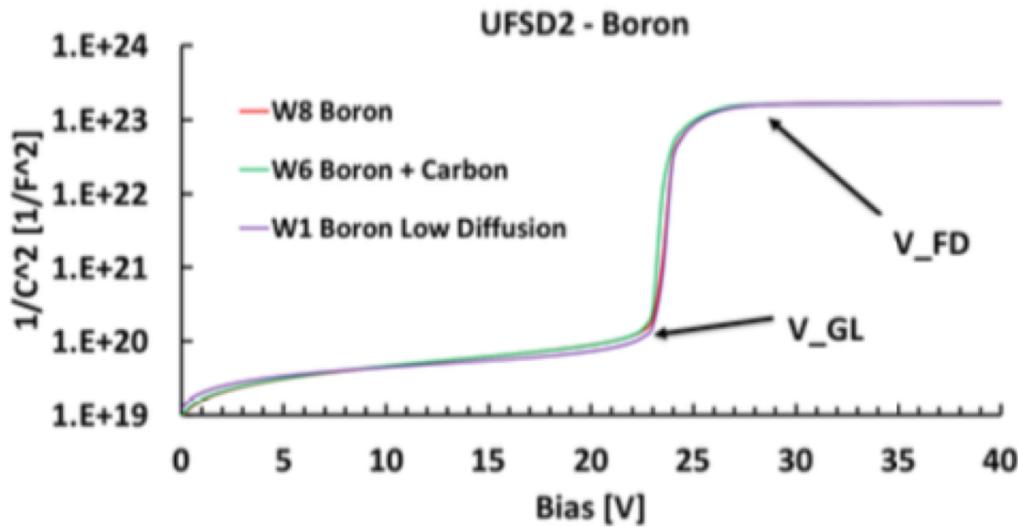
N_A = active acceptor density at fluence ϕ

g_{eff} = empirical constant ($\sim 0,02 \text{ cm}^{-1}$) → to compare with the measurements on irradiated PiN diode

c = coefficient of the acceptor removal → Dependent upon the irradiation type, the acceptor type and the initial acceptor density

For More detail on the acceptor removal model see the N. Cartiglia talk on thin workshop

Extrapolation of active acceptor density into gain layer (Method)



V_{GL} = Depletion Voltage for Gain Layer

V_{FD} = Full Depletion Voltage of sensor

V_{GL} is proportional to the amount of the active doping of the gain layer

$$V_{GL} = \frac{qN_A}{2\epsilon} w^2$$

N_A = Active doping concentration

w = thickness of the gain layer ($\sim 1 \mu\text{m}$)

q = electron electric charge

ϵ = Dielectric constant of Silicon

Extrapolation of V_{GL}

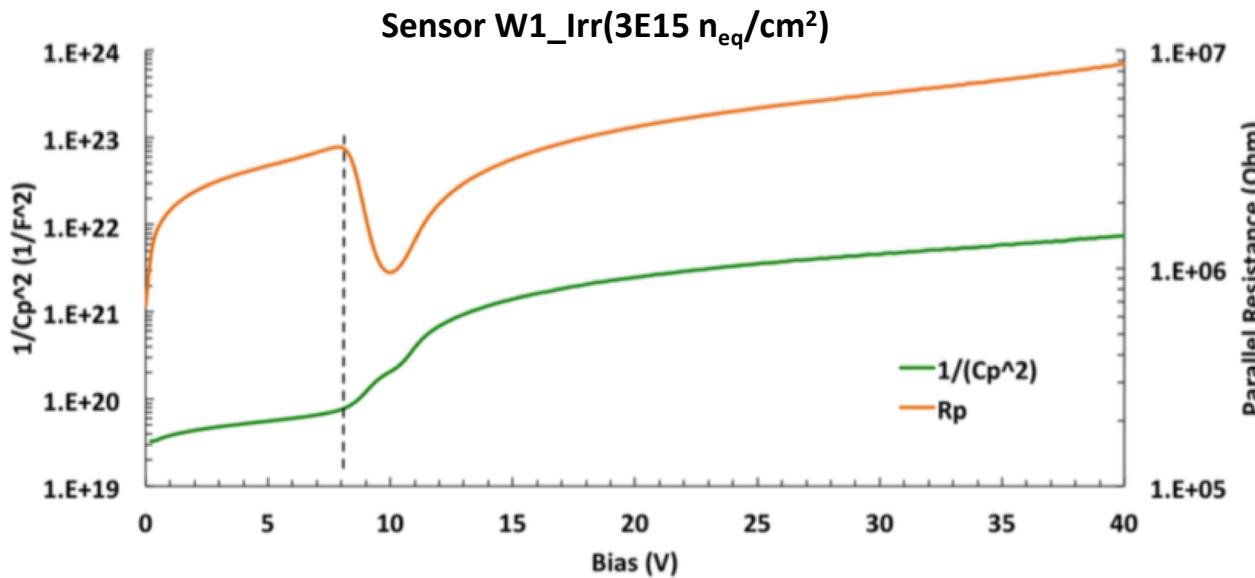
C-V Measurement parameters:

- Measurement Model = $C_p - R_p$
- Measurement Frequency = 1 kHz
- Measurement temperature = Room Temperature
- Sensors measured after annealing (80min @ 60°)

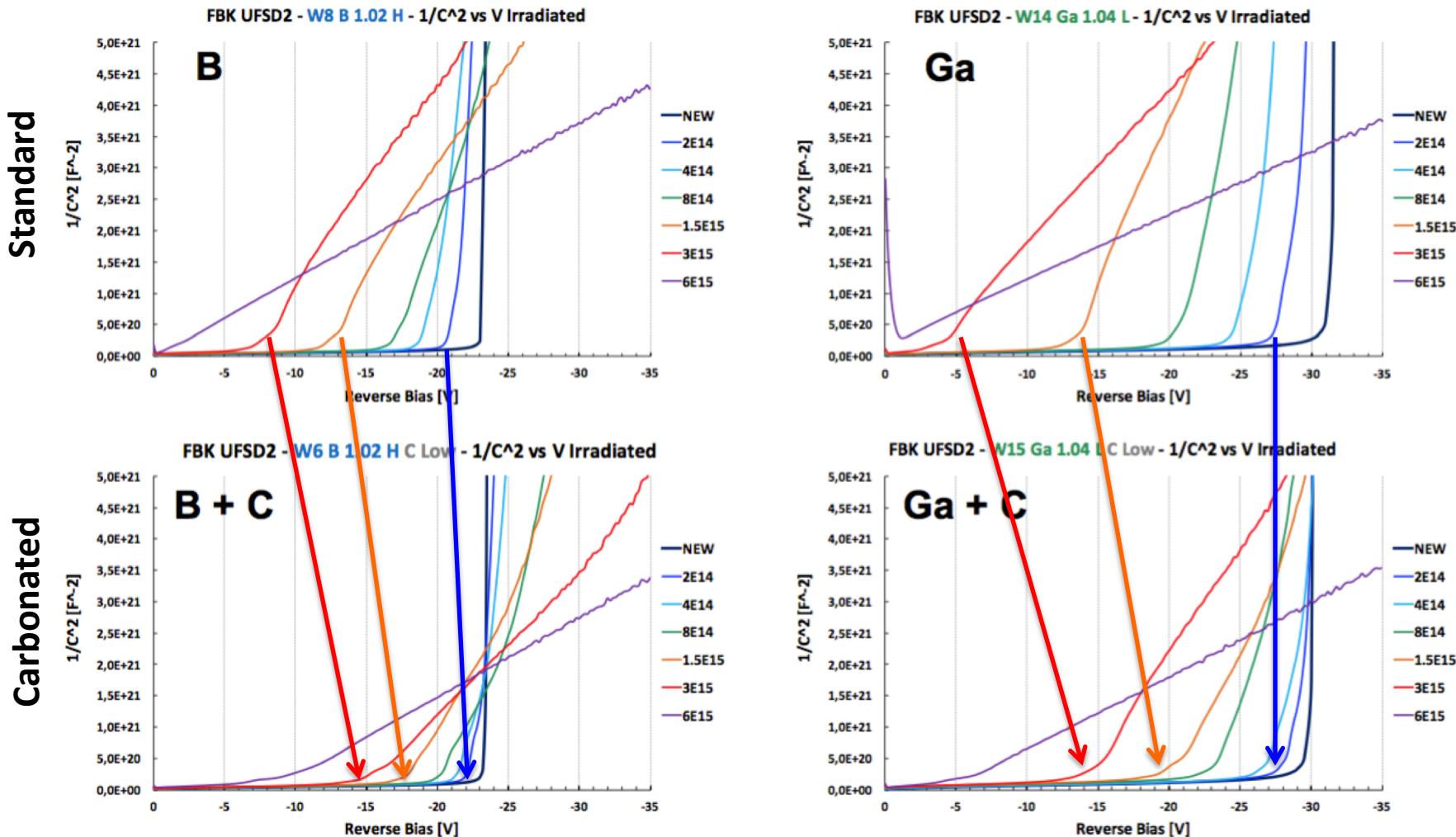
V_{GL} Extrapolation method

Using the **cusp on the R_p curve**, in coincidence with the **foot in the $1/C_p^2$ curve**

This method is precise even for fluences above $10^{15} n_{eq}/cm^2$



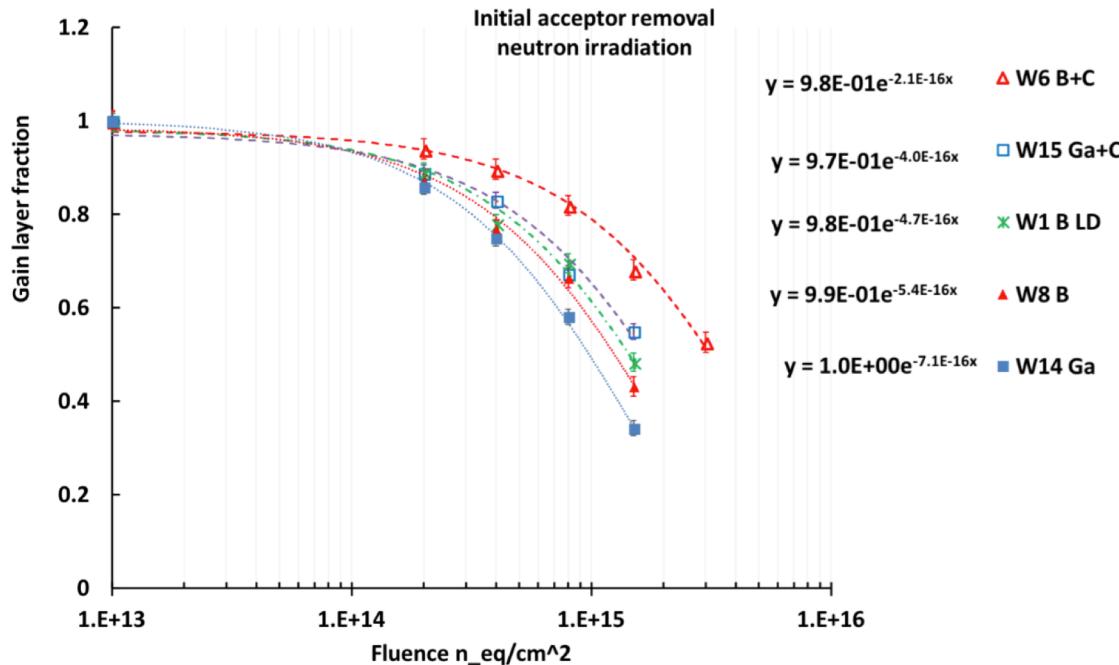
Neutrons Irradiation effects on Gain layer



Carbon implant mitigate the reduction of the active acceptor density into gain layer

Measurement of coefficient “c”

Neutrons



Fraction of active acceptor density

$$\frac{V_{GL}(\phi)}{V_{GL}(0)} = \frac{N_A(\phi)}{N_A(0)} = e^{-c(N_A(0))\phi}$$

Results:

- **Carbonated** sensors are more radiation resistant than not carbonated of a factor ~ 2
- **Gallium** is less resistant than Boron
- **Boron Low Diffusion** is more resistant than **Boron High Diffusion**

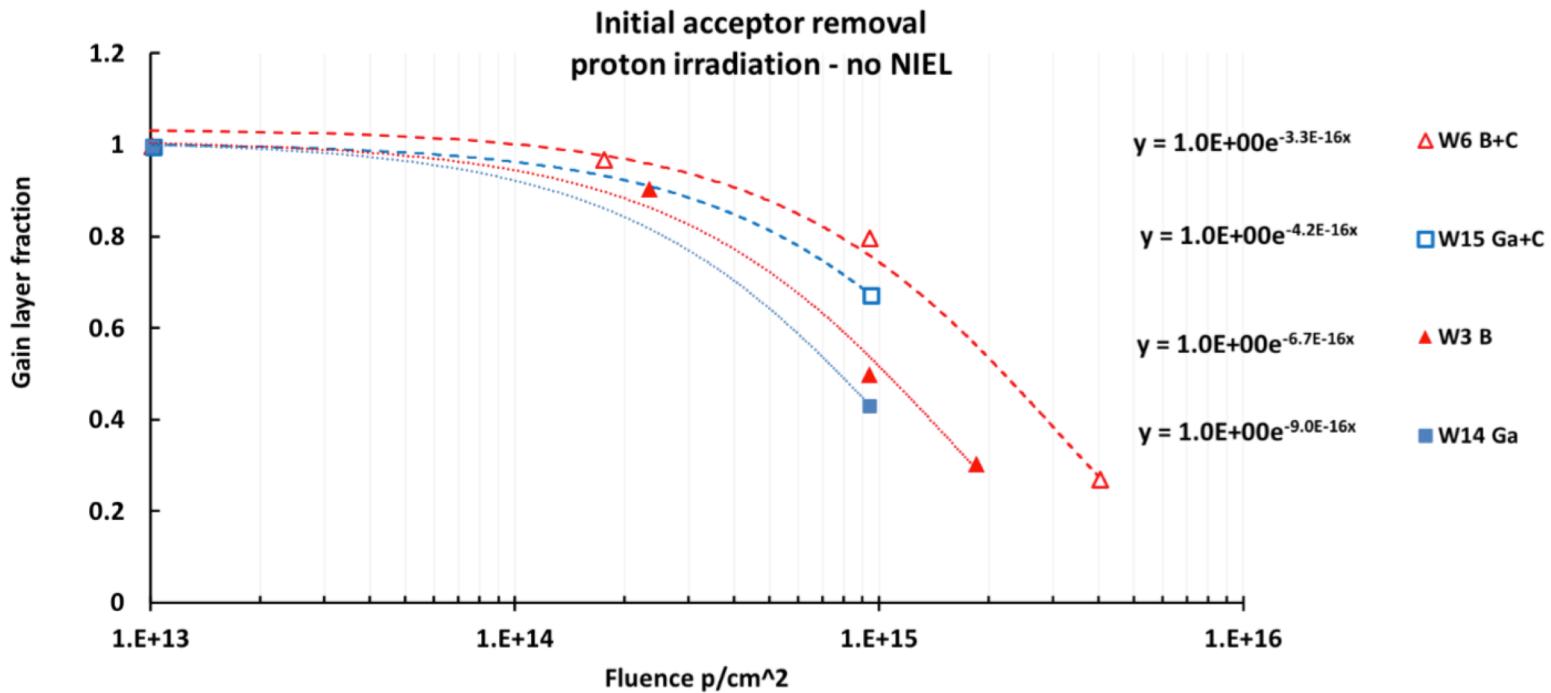
Each point on the plot is the average about two sensors

Measurement of coefficient “c”

Protons 24Gev/c

Fraction of active acceptor density

$$\frac{V_{GL}(\phi)}{V_{GL}(0)} = \frac{N_A(\phi)}{N_A(0)} = e^{-c(N_A(0))\phi}$$



In this plot the NIEL factor of 0,6 was not used

Coefficient “c” comparison between Neutrons and Protons

Gain Layer	$c_n [10^{16} \text{ cm}^2]$	$c_p [10^{16} \text{ cm}^2]$ (No NIEL)	c_n/c_p (No NIEL)	$c_p [10^{16} \text{ cm}^2]$ (NIEL)	c_n/c_p (NIEL)
Ga	7.1 ± 1.0	$9. \pm 1.5$	0.79 ± 0.22	$15. \pm 1.5$	0.47 ± 0.08
B	5.4 ± 1.0	6.5 ± 1.5	0.83 ± 0.29	10.8 ± 1.5	0.50 ± 0.11
B LD	4.7 ± 1.0				
Ga + C	4.0 ± 1.0	4.2 ± 1.5	0.95 ± 0.43	7.0 ± 1.5	0.57 ± 0.19
B + C	2.1 ± 1.0	3.3 ± 1.5	0.63 ± 0.66	5.5 ± 1.5	0.38 ± 0.54

Neutron



Proton
(No NIEL)



Proton
(NIEL)



Considering the **real value of proton fluence (p/cm^2)** the c_p coefficients (proton) and the c_n ones (neutron) are **compatible** with each other.

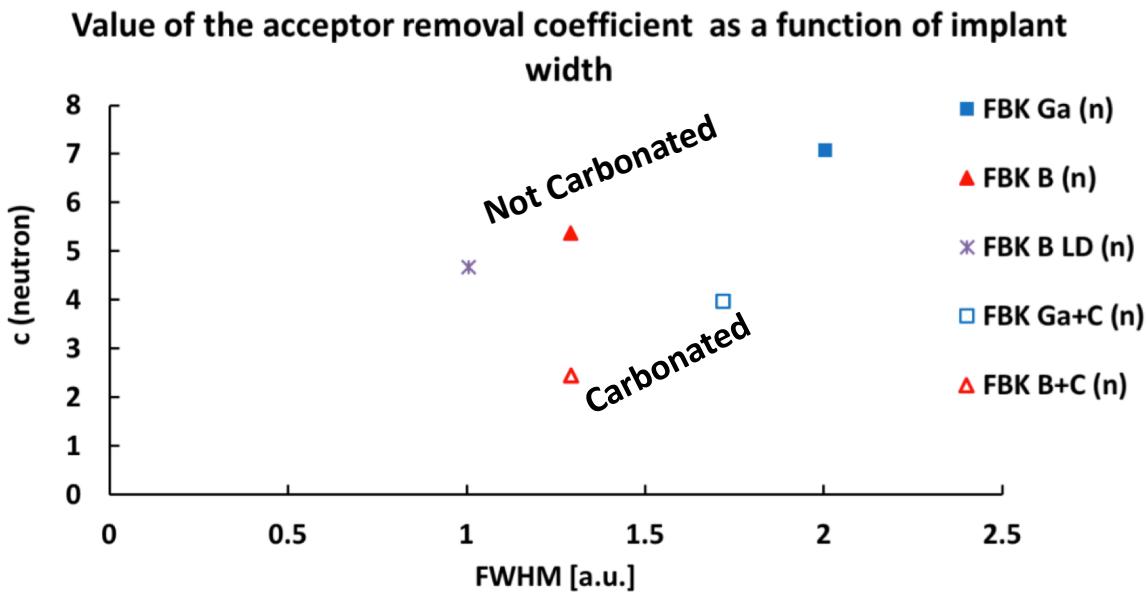
If the **NIEL factor** was applied the c_p coefficients are almost **twice** c_n

Relationship between c_n and the spatial extension of the gain layer

Wafer #	Dopant	Gain Dose	Width [a.u.]
1	B LD	0.98	1
3	B	1.00	1.3
6	B + C	1.02	1.3
8	B	1.02	1.3
14	Ga	1.04	2.0
15	Ga + C	1.04	1.7

Boron LD, Boron and Gallium has different spatial extension of gain layer

Gain layer width in arbitrary unit extracted at the FWHM of the doping profile of the implant



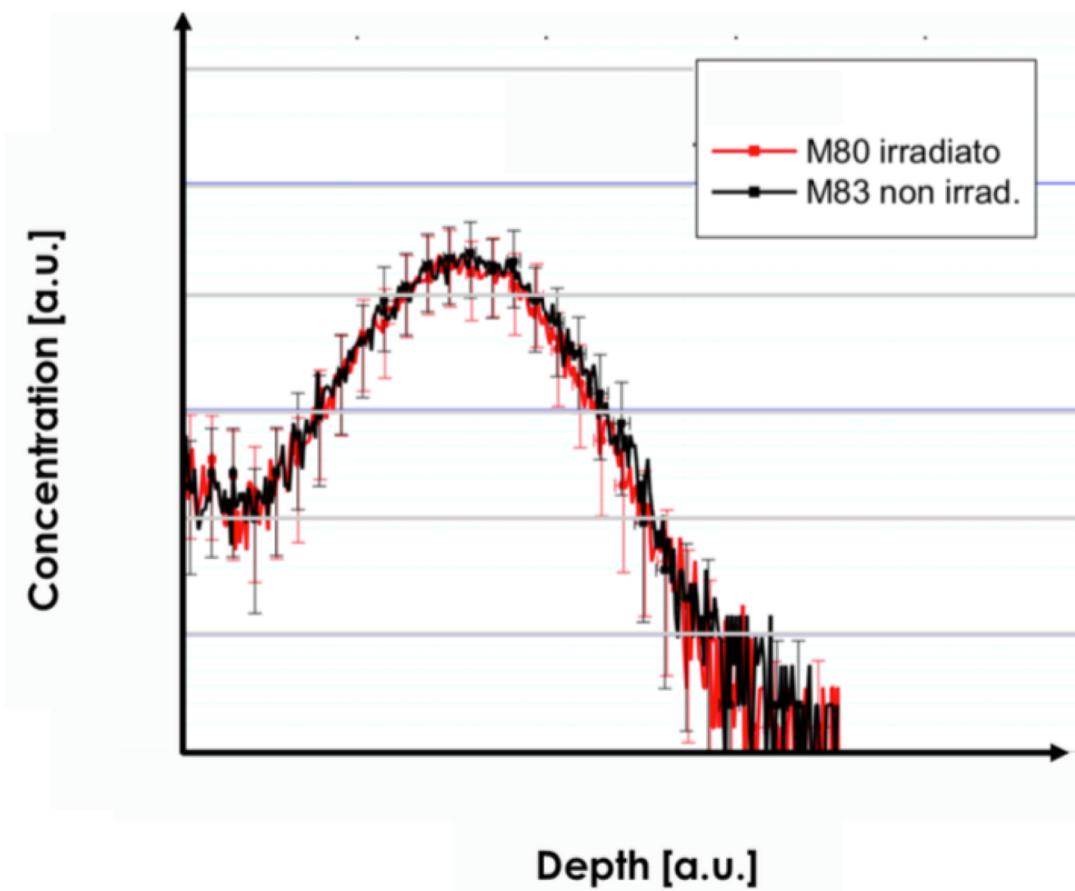
The radiation resistance is inversely proportional to the gain layer width.

The initial acceptor removal mechanism is faster for wider implant

Effect holds true for carbonate and not - carbonated sensors

Secondary Ion Mass Spectrometer (SIMS) on Irradiated LGAD $1 \cdot 10^{16}$ (n_{eq}/cm^2)

SIMS measurement shows the density of Boron atoms (active and not-active) forming the gain layer



Sensor M83
No Irradiated

Sensor M80
Irradiated $1 \cdot 10^{16} n_{eq}/cm^2$

M80 sensor has:

- **No active gain layer left**
- however it has
 - **The same spatial distribution of Boron atoms than a new sensor**

Acceptor Creation

$$N_A(\phi) = g_{eff}\phi$$

Extrapolation of acceptor density in p-bulk (Method)

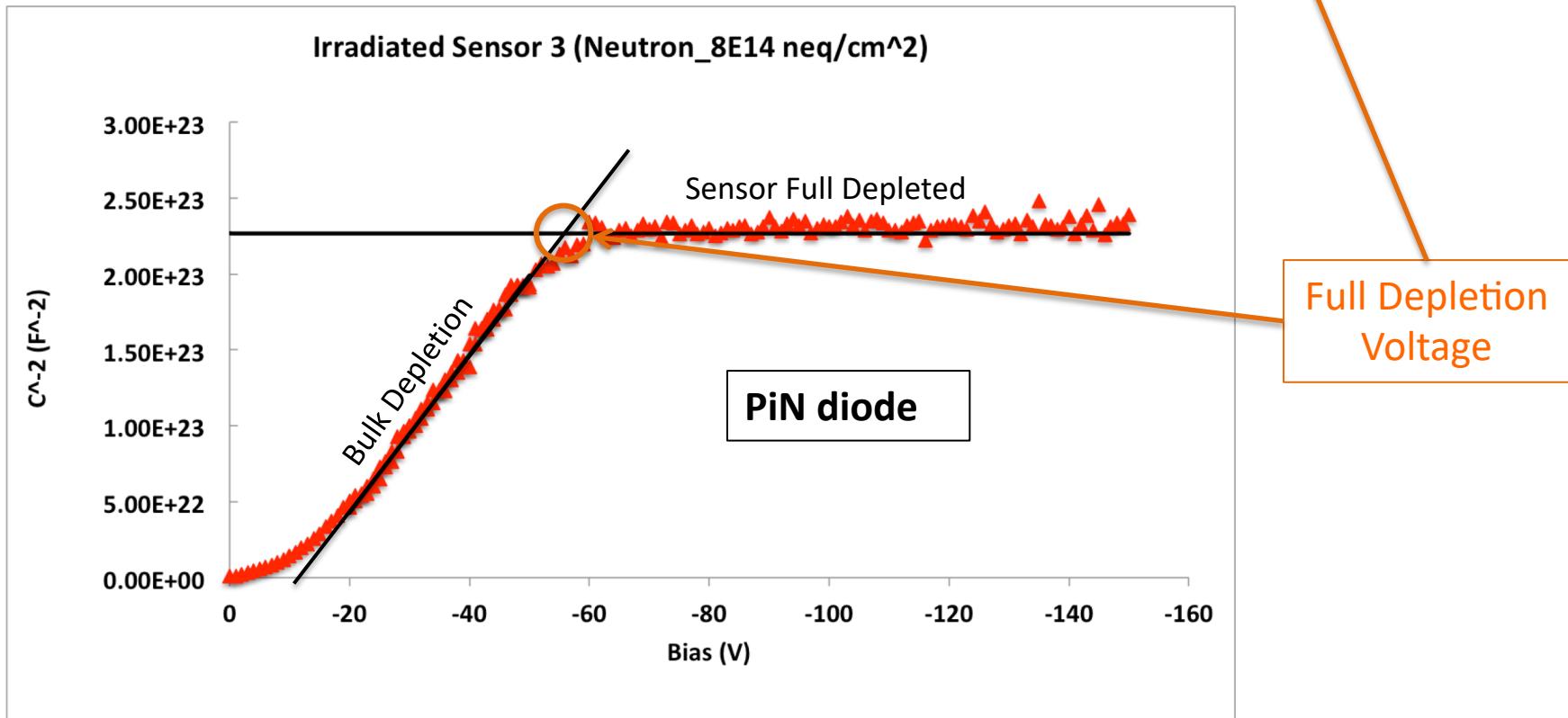
Acceptor Creation Model

$$N_A(\phi) = g_{eff}\phi$$

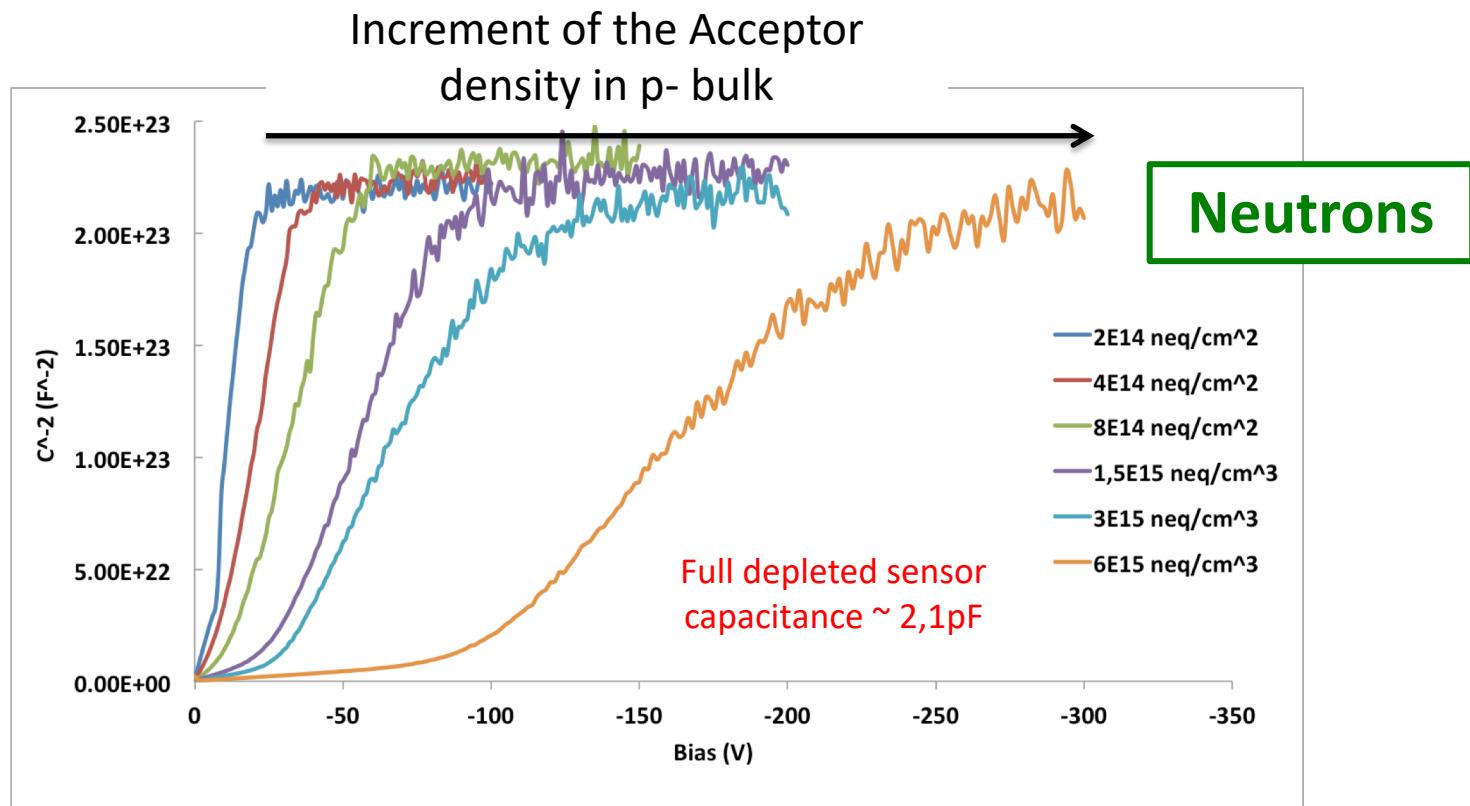
Extrapolation of acceptor density
into the p-bulk

Assuming an uniform acceptor
Creation in 50 μ m thickness

$$N_A = 2V_{FD}C^2/A^2e\epsilon_{Si}$$



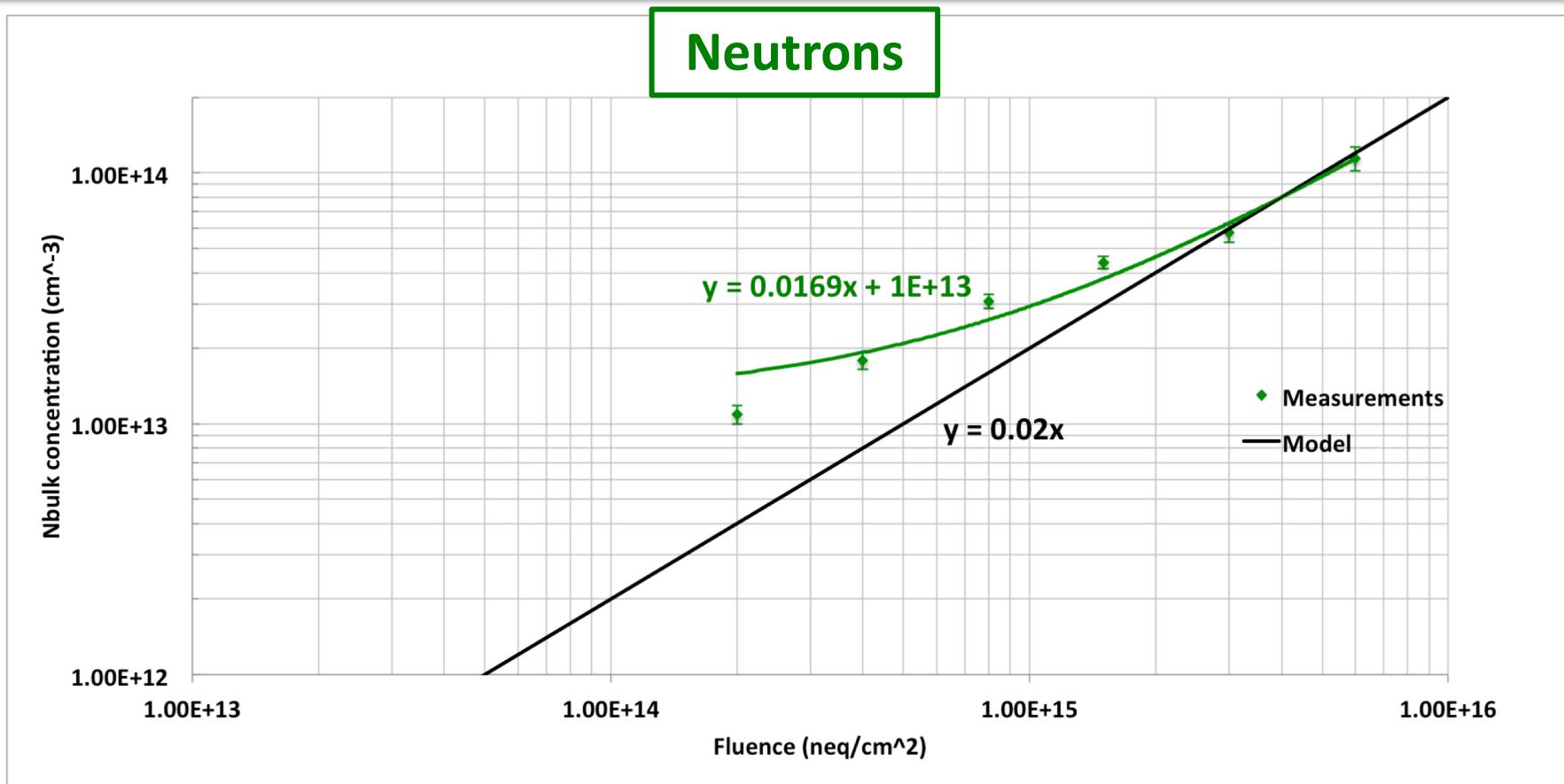
Neutrons Irradiation effects on p-bulk 50μm thick



C-V Measurement parameters:

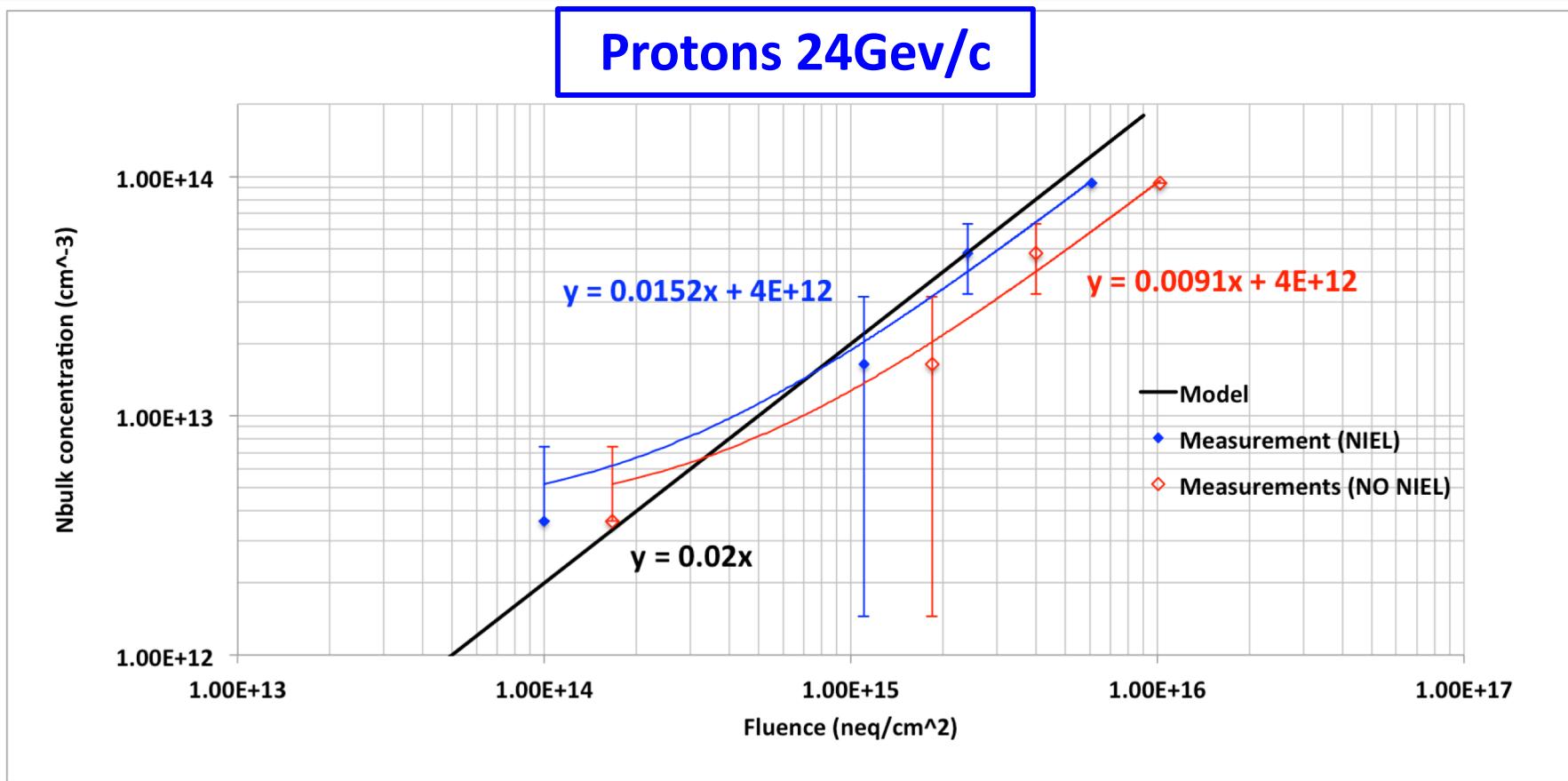
- Measurement Model = $C_p - R_p$
- Measurement Frequency = 1 kHz
- Measurement temperature = Room Temperature
- Sensors measured after annealing (80min @ 60°)

Acceptor Creation in 50μm thick PiN diodes



- High fluences ($\sim 3 \cdot 10^{15} n_{eq}/cm^2$): data in agreement with the model, $g_{eff} = 0,02 cm^{-1}$ is a good parameterization
- Low fluences ($\sim 10^{14} n_{eq}/cm^2$): increasing of the distance between data and model as fluences decrease, **is it possible a not complete acceptor removal?**

Acceptor Creation in 50μm thick PiN diodes



- Applying the NIEL there is an agreement between data and model at fluences $\sim 10^{15} \text{ n}_{\text{eq}}/\text{cm}^2$
- Without NIEL Factor the parameterization of g_{eff} is lower than $0,02\text{cm}^{-1}$

Summary

- The addition of Carbon to the gain layer improves the radiation resistance, the c coefficients are about a factor of two smaller for B+C and Ga+C than B and Ga
- The c_p coefficients of acceptor removal are comparable with c_n coefficients considering the real protons fluence. Instead applying the NIEL Factor to the protons fluence the c_p coefficients are almost twice c_n .
- Thinner and more doped gain layer implants are less prone to initial acceptor removal: B LD has a lower c_n coefficient than B.
- Acceptor Creation measurements on neutrons irradiated PiN diodes are in agreement with the model $N_A = g_{eff}\Phi$ ($g_{eff} = 0,02 \text{ cm}^{-1}$) for fluences above $10^{15} n_{eq}/\text{cm}^2$
- Acceptor Creation measurements on protons irradiated PiN diodes are comparable with results obtain with neutrons if the NIEL Factor is used. Considering the real protons fluence, the g_{eff} parameter is lower than $0,02 \text{ cm}^{-1}$

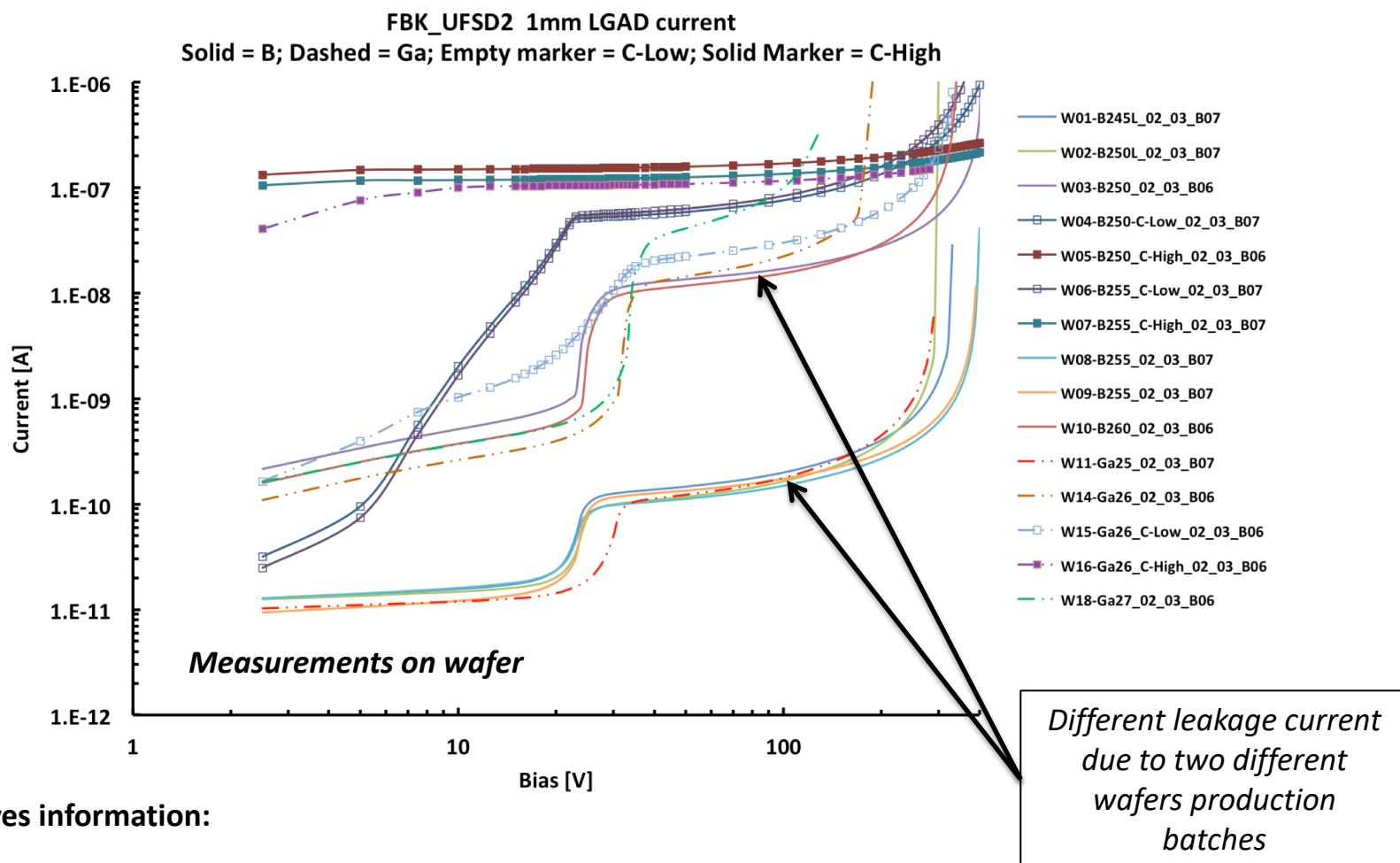
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- Horizon 2020, grant INFRAIA
- Ministero degli Affari Esteri, Italy, MAE, “Progetti di Grande Rilevanza Scientifica”
- U.S. Department of Energy grant number DE-SC0010107
- Grant Agreement no. 654168 (AIDA-2020)

Backup

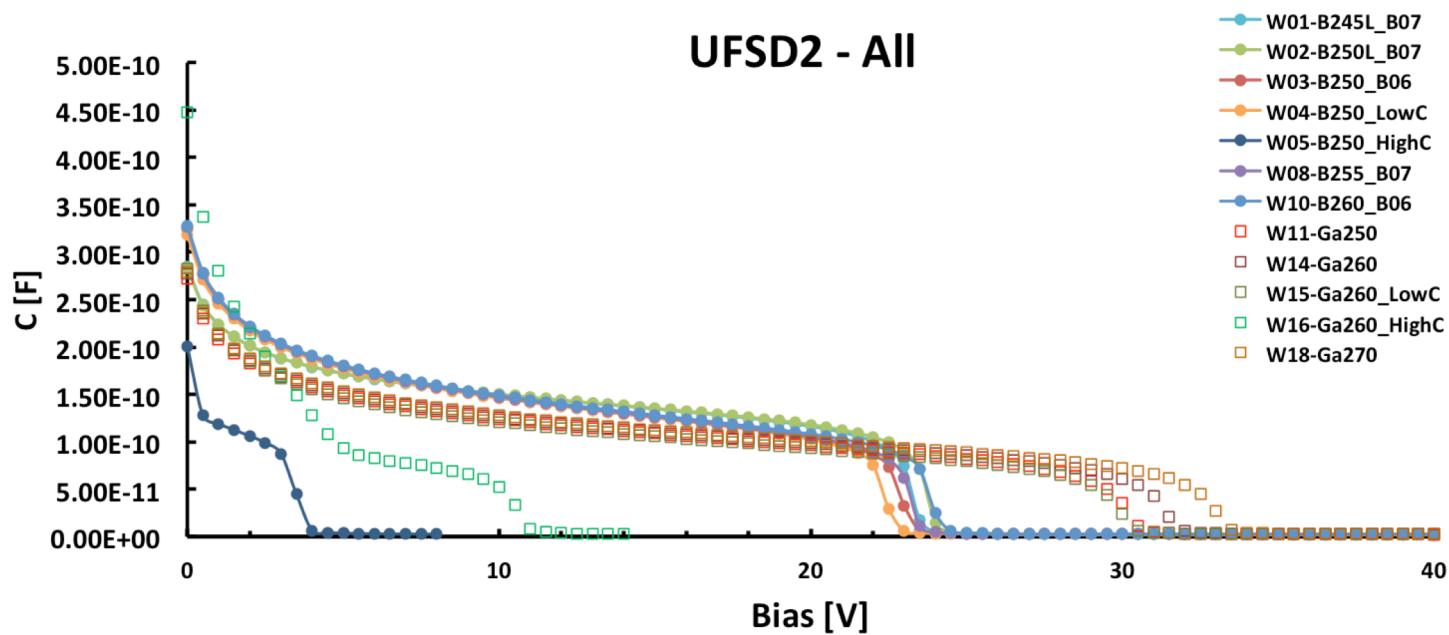
IV Curve on UFSD2 (Not Irr)



IV Curves information:

- Boron and Gallium doped sensors show the same behavior;
- Low leakage current ($>10s\text{ pA}$; $<10s\text{ nA}$);
- The knee at $\sim 30\text{V}$ proves the gain layer implant;
- Current Exponential growth gives an information about the internal gain of the sensors;

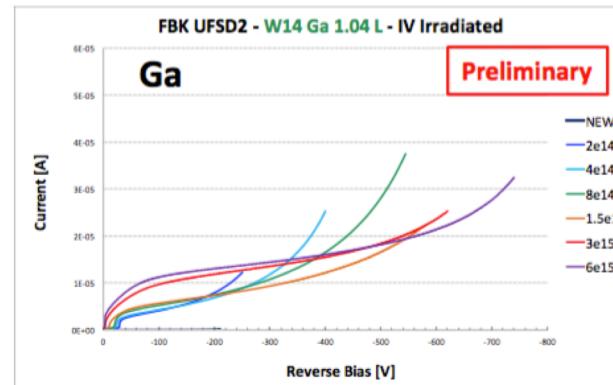
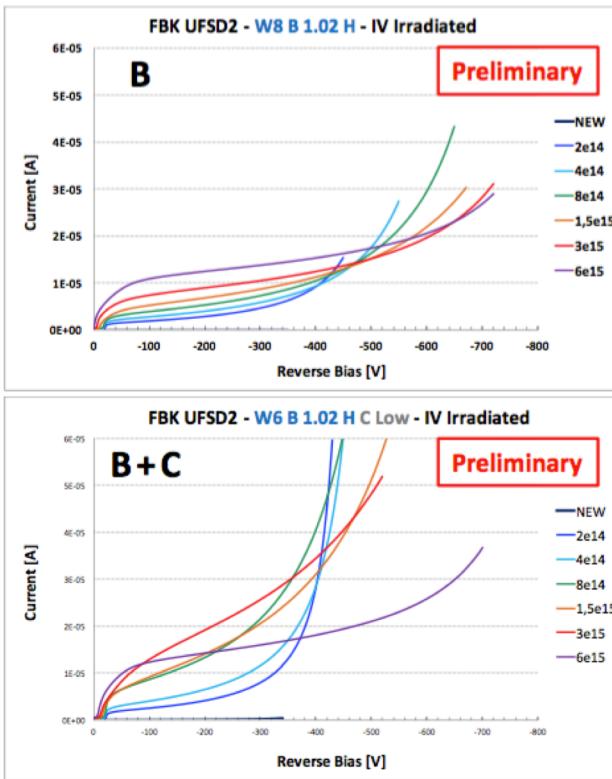
CV Curves of UFSD2 (Not Irr)



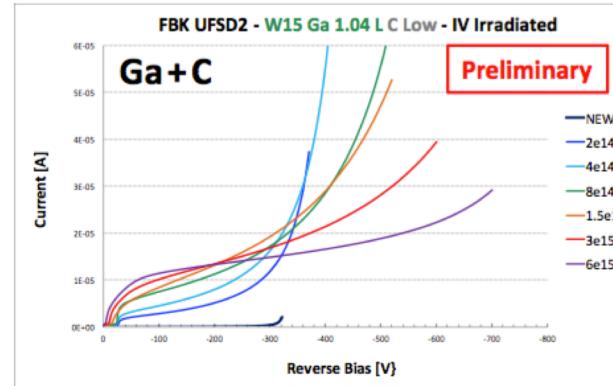
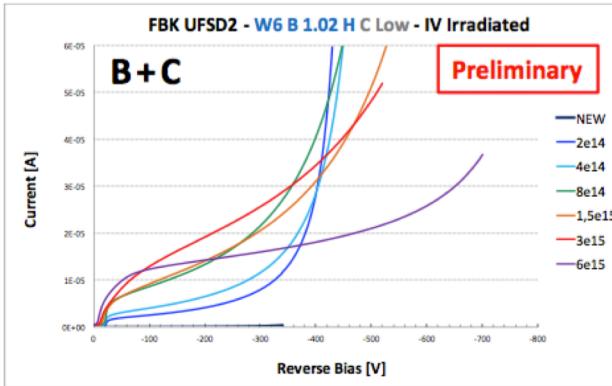
CV Curves of all wafer (B/Ga/B-C/Ga-C)

IV Measurements on Irradiated Sensors

Standard



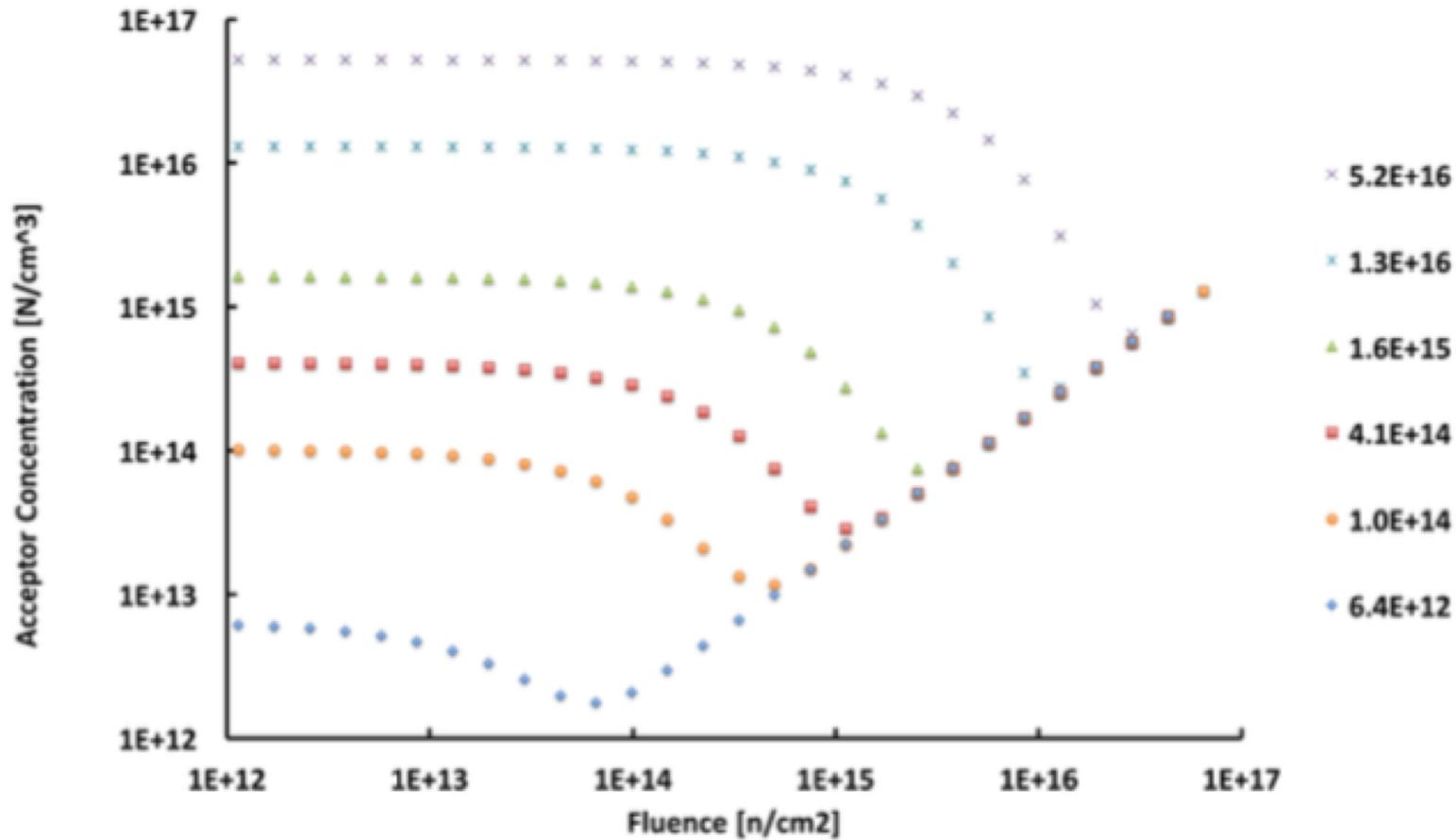
Carbonated



Curvature proportional to gain

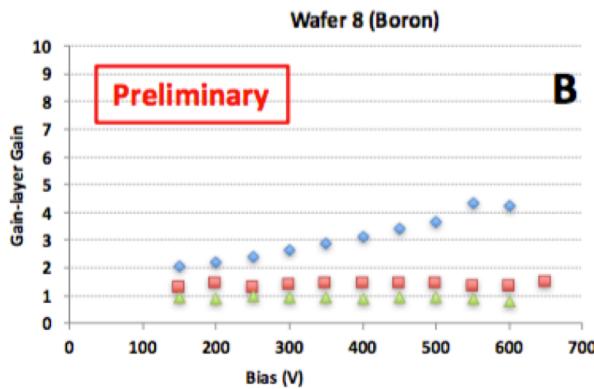
Irradiation extends the operating voltage of the sensors up to ~ 750 V

Initial acceptor removal + Acceptor Creation

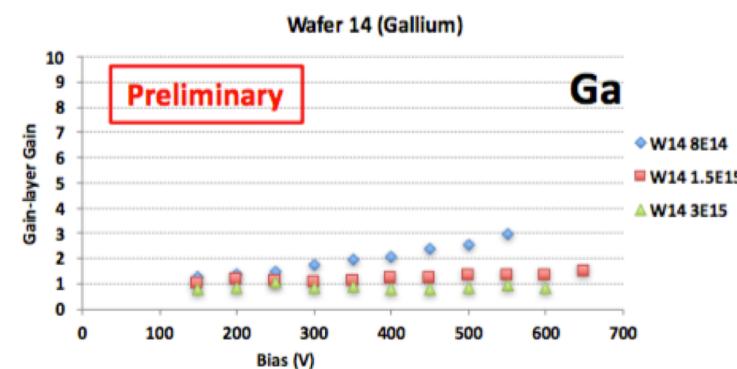


Gain Of Irradiated sensors

Standard

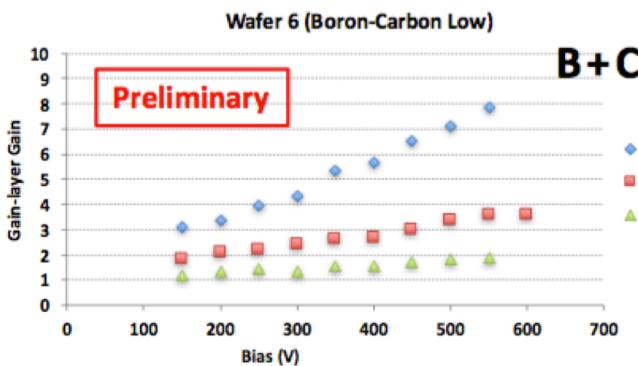


B

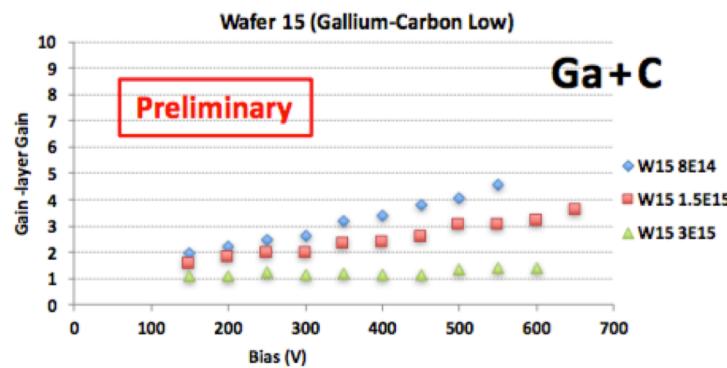


Wafer 14 (Gallium)

Ga



B+C

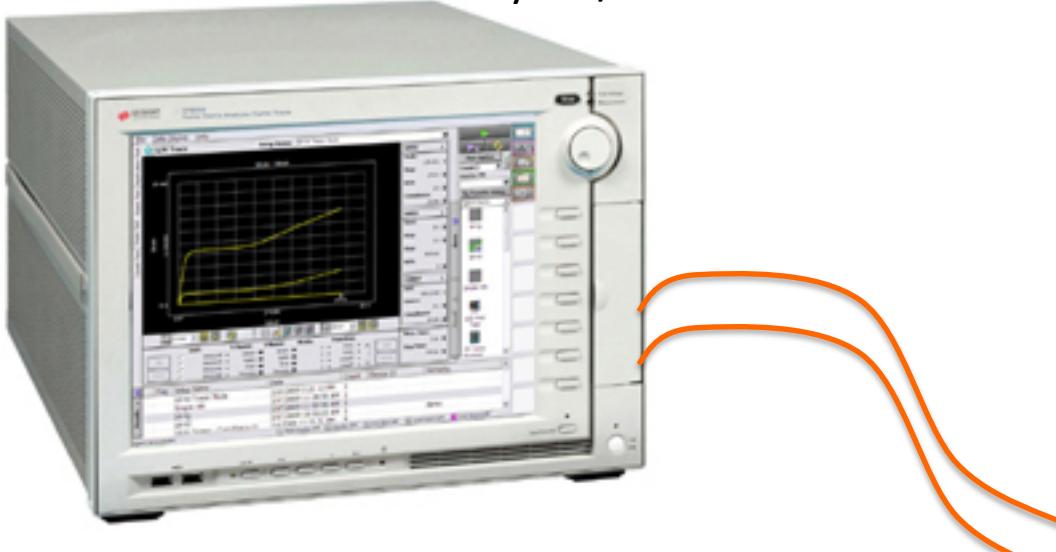


Ga+C

- Carbonated Boron at ~ 600 V maintains factor 2 higher gain than standard Boron

CV measurements (laboratory setup)

Keysight
B1505A Power Device Analyzer / Curve Tracer



Probe station

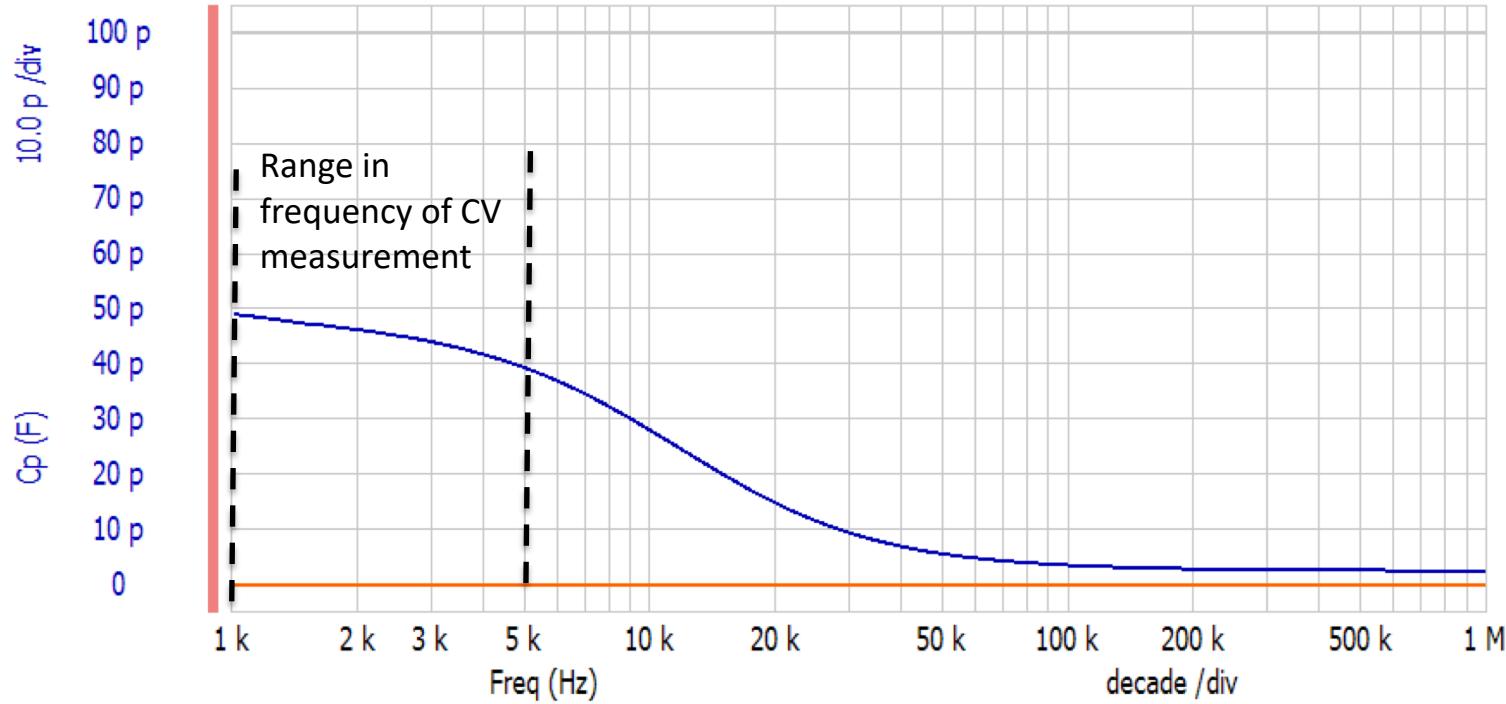


Modules

- High Voltage SMU: Max Range ($\pm 3000V$, $\pm 4mA$);
Min Range (200V, 1nA);
- CMU Modules: Range In frequency (1khz-1MHz);

Cf measurements of irradiated sensor $(3 \cdot 10^{15} n_{eq}/cm^2)$

Cf measurements of an LGAD sensors (Wafer 8, Boron) irradiated with neutrons (fluence = $3 \cdot 10^{15} n_{eq}/cm^2$)



(S)

5 m

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Acceptor Creation

